

## UPLAMP 2024 Summer School on Ultra-short Pulse Lasers Applications in Material Processing

### Students Oral Presentations Programme

	July 1	July 2	July 3	July 4
Time:	Session 1	Session 3	Session 5	Session 6
12:30	<b>Yuan Xu</b> Multiscale Computational Study of Surface Modification by Nonlinear Laser-Induced Surface Acoustic Waves	<b>Srivathsa Venkatesh</b> Thin Film Deposition and patterning	<b>Jia-Fan Kuo</b> High-quality structures on 4H-SiC fabricated by femtosecond laser	<b>Shang Yu Hsu</b> Introduction of Ultrafast Laser Technology Research and Innovation Center in ITRI
12:42	<b>Chaobo Chen</b> Atomistic Modeling of Pulsed Laser Ablation in Liquid	<b>Dainius Balkauskas</b> Electrodes formation by laser induced copper deposition on glass for innovative smart windows	<b>Patrick Hildebrand</b> Improving 2PP printing freedom with 3D beam shaping and intensity accumulation	<b>Ching Chan Chen</b> Ultrafast Laser Material Modification Process Application at ITRI
12:54	<b>Luis Omeñaca</b> Optimizing Ultrafast Laser Ablation: Experimental analysis and two-temperature model enhancement with multi-pulse and incubation considerations	<b>Šarūnas Mickus</b> Investigation of the Formation of Electrically Conductive Zones on Dielectric Surfaces by Laser-Induced Metallization and Graphene Formation	<b>Soheil Alee Mazreshadi</b> Optimizing Laser Parameters for Robust Bonding in Multiphoton Polymerization: A Parametric Study	<b>Jyun-Jhih Wang</b> Applications of Ultra-Fast Laser Micro-Processing
13:06	<b>Evaldas Kazūkauskas</b> Exploring the dynamic surface roughness evolution of fused silica under multilayer ablation conditions using femtosecond laser pulses	<b>Justina Žemgulytė</b> Effects of Different Manufacturing Techniques on the Performance of Planar Antennas	<b>Jaime Cuartero</b> Beam parallelization for increased productivity Two-Photon Polymerization by means of Spatial Light Modulators	<b>Yongting Yang</b> Ultrashort pulsed laser robot system: A step forward towards flexible and 3D laser micromachining
13:18	<b>Vishnu Prakash Karunakaran</b> Femtosecond Laser Micromachining for Quantum Photonics Devices	<b>Mohamed Ahmed Baba</b> Micromachining of solid oxide fuel cell	<b>Darija Astrauskytė</b> Reducing reflection losses in multi-level micro-optics made by femtosecond laser direct writing	<b>Dominik Mücke</b> Towards Automated Hybrid Laser Processing of Fused Silica

	<b>Session 2</b>	<b>Session 4</b>		<b>Session 7</b>
<b>15:30</b>	<b><i>Kernius Vilkevičius</i></b> The periodic plasmonic nanostructures with tunable morphology produced using femtosecond pulses	<b><i>Dirk Obergfell</i></b> Investigation of the Influence of Pulse Width and Different Burst Modes on Ablation Characteristics of different types of stainless steel		<b><i>Alireza Shahidi</i></b> Enhanced Production of Gold Nanoparticles via Ultrasonic Cavitation and Ultrashort Pulse Laser Irradiation
<b>15:42</b>	<b><i>Rodrigas Liudvinavičius</i></b> Plasmonic microbump grating resilience to the immersion into liquids for practical applications	<b><i>Natalia Grudzień</i></b> Increasing the removal rate of metals with femtosecond fiber laser		<b><i>Vita Petrikaitė</i></b> Generation of bimetallic nanoparticles from thin gold and silver films on glass substrate and use for SERS enhancement
<b>15:54</b>	<b><i>Eulàlia Puig Vilardell</i></b> 3D Photonic Crystal for Rainbow Trapping Fabricated via Two-Photon Lithography	<b><i>Robin Klöpfer</i></b> Influence of heat accumulation on the melt film thickness and surface structure occurrence during laser percussion drilling		<b><i>Gazy Khatmi Rodowan Albedry</i></b> Lateral Flow Assay Sensitivity and Signal Enhancement via Laser $\mu$ -Machined Constrains in Nitrocellulose Membrane
<b>16:06</b>	<b><i>Indrė Meškėlaitė</i></b> Pathway towards femtosecond direct laser writing of waveguides in transparent media for optical neural networks	<b><i>Fabian Ränke</i></b> High-speed laser surface texturing by combining direct laser interference patterning with polygon scanner technology		<b><i>Artur Harnik</i></b> YAG:Ln for laser 3D lithography: precursor synthesis and study
<b>16:18</b>	<b><i>Edvinas Aleksandravičius</i></b> Suppression of filamentation by photonic crystals	<b><i>Rimantas Naina</i></b> Selective laser etching of fused silica using low numerical aperture focusing objective		<b><i>Jaroslav Jacak</i></b> 3D multiphoton -lithography of protein-based scaffolds for stem cell studies